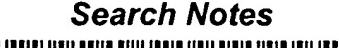


Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/672,429	DEMPCY ET AL.
	Examiner	Art Unit
	Ritesh Agrawal	1631

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner